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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/936,967 02/25/2002		Paul Kadlec	1074-045-PWH	3047
21034 7.	590 03/01/2004		EXAMINER	
IPSOLON LLP 805 SW BROADWAY, #2740 PORTLAND, OR 97205			CRUZ, MAGDA	
			ART UNIT	PAPER NUMBER
•			2851	

DATE MAILED: 03/01/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
	09/936,967	KADLEC, PAUL			
Office Action Summary	Examiner	Art Unit			
	Magda Cruz	2851			
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the c	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPL' THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a repl - If NO period for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be tim y within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from , cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on 21 N					
,—	a) ☐ This action is FINAL . 2b) ☐ This action is non-final.				
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims					
4) ⊠ Claim(s) 1-25 is/are pending in the application 4a) Of the above claim(s) is/are withdray 5) ⊠ Claim(s) 7-18 and 20-25 is/are allowed. 6) ⊠ Claim(s) 1,3-6 and 19 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction and/or	wn from consideration.				
Application Papers					
9) ☐ The specification is objected to by the Examine 10) ☐ The drawing(s) filed on 25 February 2002 is/are Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) ☐ The oath or declaration is objected to by the Examine 11.	e: a)⊠ accepted or b)□ objected drawing(s) be held in abeyance. Seetion is required if the drawing(s) is obj	e 37 CFR 1.85(a). lected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119		o			
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	on No ed in this National Stage			
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:				

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) and the Intellectual Property and High Technology Technical Amendments Act of 2002 do not apply when the reference is a U.S. patent resulting directly or indirectly from an international application filed before November 29, 2000. Therefore, the prior art date of the reference is determined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

2. Claims 1, 3-6 and 19 are rejected under 35 U.S.C. 102(e) as being anticipated by Wang et al.

The applied reference has a common inventor with the instant application.

Based upon the earlier effective U.S. filing date of the reference, it constitutes prior art under 35 U.S.C. 102(e). This rejection under 35 U.S.C. 102(e) might be overcome either by a showing under 37 CFR 1.132 that any invention disclosed but not claimed in the reference was derived from the inventor of this application and is thus not the invention "by another," or by an appropriate showing under 37 CFR 1.131.

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Wang et al. (US Patent Number 6,473,179 B1) discloses an integrated photoelastic modulator (24) and diagnostic system (50) comprising: a photoelastic modulator (24) including an optical element (25) having a primary aperture through which primary light directed (column 3, lines 18-20), and a diagnostic system (50) including a diagnostic light source (76) for directing through the optical element diagnostic light (74) that is distinct from the primary light, wherein the diagnostic light source (76) is configured so that the diagnostic light (Bi) is directed through the optical element (76) at a location remote from the primary aperture; wherein the photoelastic modulator (24) is operable to provide retardance characteristics in primary light that is directed through the optical element, and wherein the diagnostic system includes processing means for determining at least one retardance characteristic provided by the photoelastic modulator (column 3, lines 42-51); including display means (92) for displaying the retardance characteristic determined by the processing means (90); including feedback means for converting signals representing the determined retardance characteristic into control signals (column 6, lines 31-36) for the photoelastic modulator (84); wherein the photoelastic modulator (24) is operable to provide retardance characteristics in primary light (Bi) that is directed through the optical element (30), and wherein the diagnostic system includes processing means for determining a retardance characteristic of the diagnostic light and using the retardance characteristic of the diagnostic light to calculate a retardance characteristic in the primary light that is provided by the photoelastic modulator (column 5, lines 17-23).

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Allowable Subject Matter

- Claims 7-18 and 20-25 allowed.
- 4. The following is a statement of reasons for the indication of allowable subject matter:

The prior art does not teach an integrated photoelectric modulator and diagnostic system, comprising in combination with the additionally recited elements, a method of operating said photoelastic modulator that is operable for vibrating an optical element to impart retardance characteristics in a primary light beam that is directed through the optical element; a source of diagnostic light arranged to transmit diagnostic light through the optical element at a second location that is spaced from the first location so that the optical element imparts retardance characteristics that are different from the retardance characteristics imparted in the primary light beam and a detector arranged for detecting at least a portion of the diagnostic light transmitted through the second location of optical element; processing means for extrapolating from the detected diagnostic light a retardance characteristic imparted by the photoelastic modulator to the primary light.

Conclusion

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Oakberg (US Patent Number 5,652,673) discloses an elimination of modulated interference effects in photoelastic modulators.

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Siahpoushan et al. (US Patent Number 5,886,810) teaches a mounting apparatus for an optical assembly of a photoelastic modulator.

Wang et al. (US 2003/0020911 A1) shows a practical system and method for precisely measuring retardance and fast axis orientation.

6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Magda Cruz whose telephone number is (571)272-2114. The examiner can normally be reached on Monday through Thursday 8:00-5:30 PM.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Russ Adams can be reached on (571)272-2851. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

RUSSELL ADAMS
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2300